

# Overview of optical characterisation capabilities for assessing suitability of optics for high-energy, high repetition rate lasers

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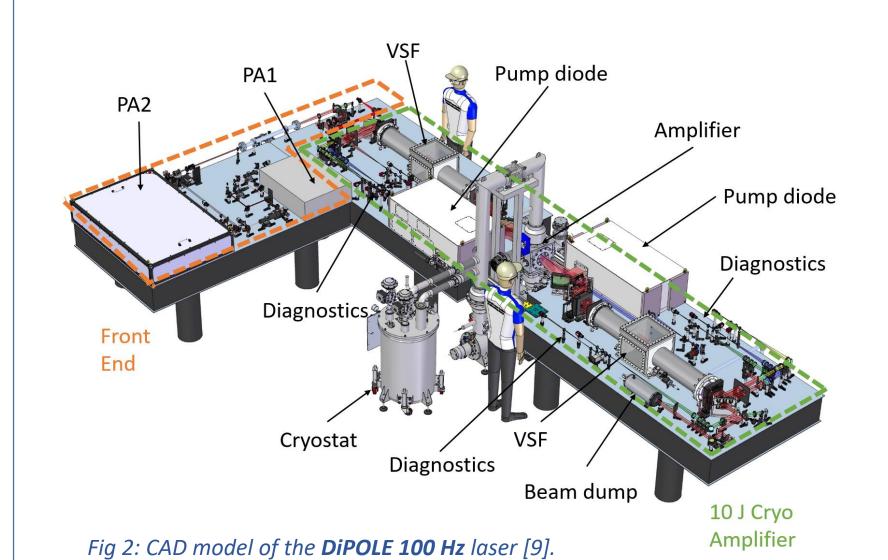
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## Abstract

- The DiPOLE concept is a world-leading, high average power laser technology based on diode-pumped, cryogenically cooled Yb:YAG amplifiers [1] combining multi-J pulses with multi-Hz repetition rates and high efficiency.
- High energy, high repetition rate lasers are required for applications in industry, science and medicine including laser shock peening [2], inertial confinement fusion [3] and high-resolution, time-resolved imaging [4].
- For successful operation of such lasers, high-quality components that fully comply with our specifications are required.
- To ensure optical components comply, we have devised a range of setups for optical characterisation which are detailed below.

## Introduction to DiPOLE lasers

- Based on the DiPOLE concept [5]
  - **Di**ode **P**umped **O**ptical **L**aser for **E**xperiments
  - Multi-pass, multi-slab, cryogenically-cooled, Yb:YAG (1030 nm) laser amplifier architecture



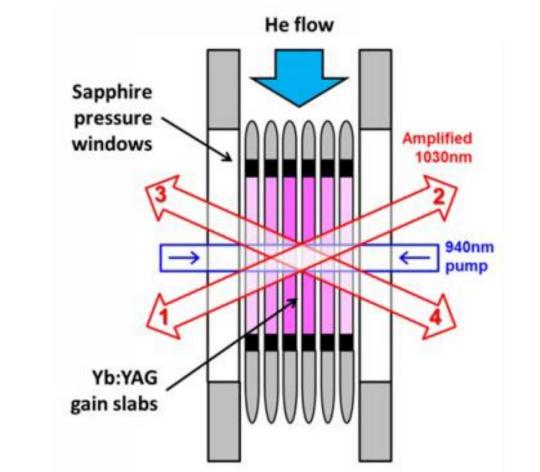


Fig 1: Schematic of DiPOLE 10 J amplifier head [6].

- DiPOLE technology is scalable in both energy and pulse repetition rate
- **Evolution of DiPOLE lasers:** 
  - DiPOLE 10 J, 10 Hz (100 W) [6]
  - DiPOLE 100 J, 10 Hz (1 kW) [7,8]
  - DiPOLE 10 J, 100 Hz (1 kW) [9]

## 2. Transmittance/Reflectance

- Anti-reflection coatings ensure high transmittance through optics, e.g. lenses, windows
  - AR coated lenses should have reflectivity ≤ 0.15% at 1030 nm
- **High-reflectance coatings** ensure minimal leakage through optics upon reflection, e.g. mirrors
  - 45° HR coatings should have reflectivity (at 1030 nm):
  - ≥ 99.95% (p-pol)

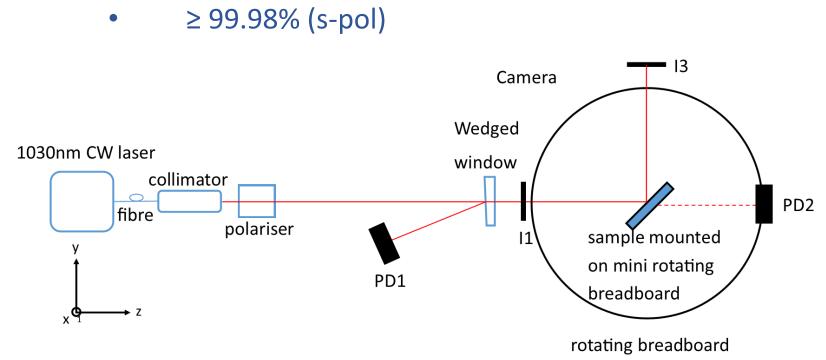


Fig 3: Layout of the setup used for measuring the transmittance and reflection of optical coatings over a range of angles.

(a)

Fig 4: Experimental results for the transmittance of (a) pand (b) s- polarised light through a number of samples from different suppliers with reflection optimised for 45°.

Angle of camera wrt reflected beam (°)

a number of HR mirror samples from different suppliers with

reflection optimised for 45°.

ARS of a 45° mirror is measured at a

range of angles with respect to the

specular reflection in the plane of

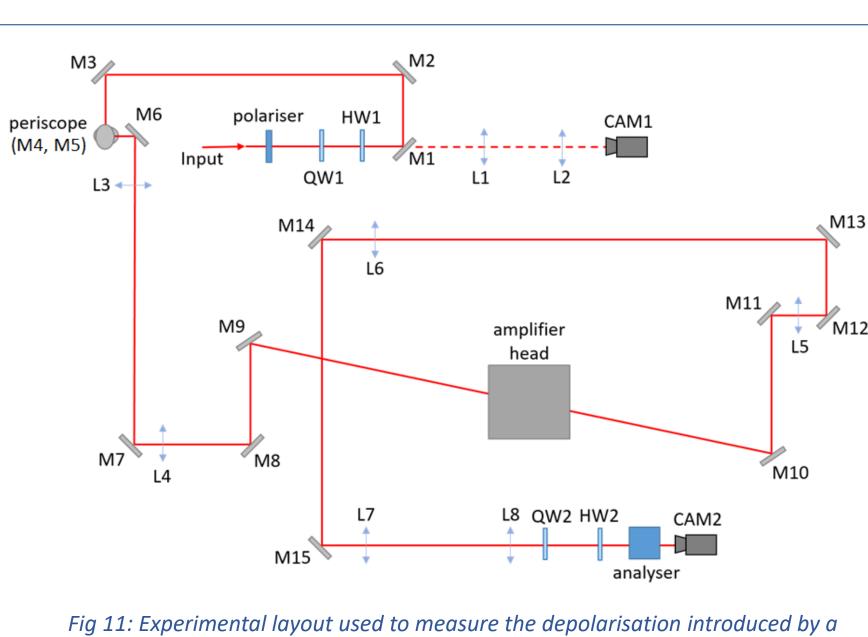
ARS cannot be isolated from specular

reflection hence the gap around 0° in

# Angle of sample wrt incident beam (°

## Polarimetry

- **Depolarisation**: where the polarisation state of the transmitted beam varies across the beam aperture due to stressinduced birefringence
- Removal of depolarisation allows for more output energy to be achieved as well as making polarisation sensitive processes, e.g. frequency conversion, more efficient



single-pass through the 100 J amplifier head in a DiPOLE 100 J, 10 Hz laser.

Input polarsation circular 90° linear **EXPERIMENT** 

 Experimental results show the input polarisation state has an impact on the degree of depolarisation

Fig 12: Experimental depolarisation patterns (with same scale).

## Damage Resilience

- **High damage resilience** is important for the optical components in DiPOLE lasers as the fluence reaches high values at high energies
- Intensity hotspots and fluctuations can also lead to areas of higher fluence which the optical components need to be resilient to
- Optics tested in DiPOLE 10 J, 10 Hz system up to 7 J/cm<sup>2</sup>

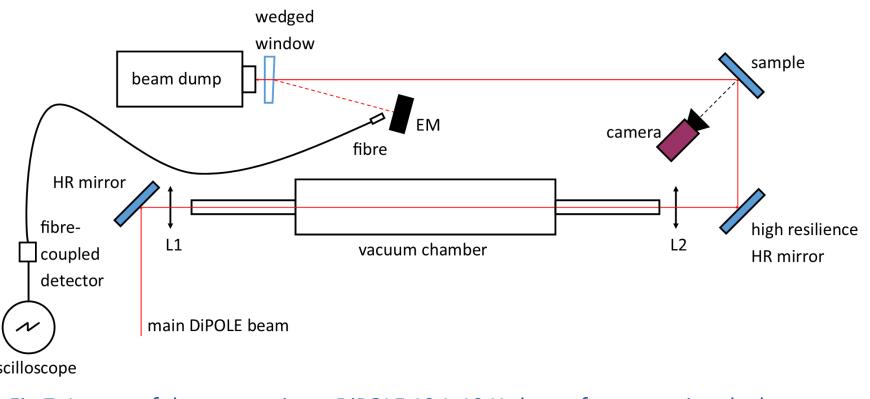
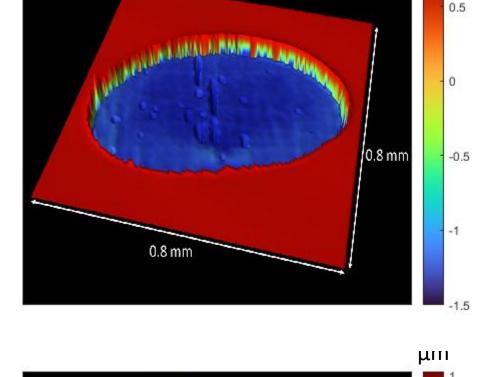


Fig 7: Layout of the setup using a DiPOLE 10 J, 10 Hz beam for measuring the laser induced damage threshold of optics using a 10 mm x 10 mm beam.



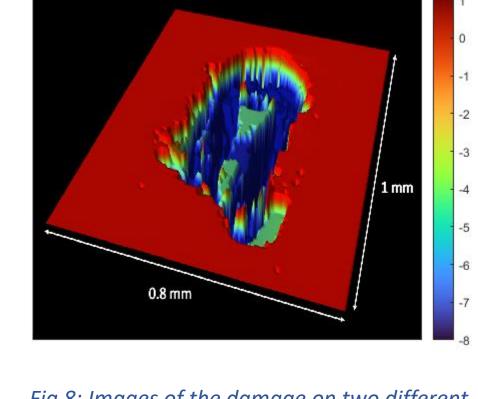


Fig 8: Images of the damage on two different optical coatings that was introduced when the fluence of the beam became too high as taken using a white light interferometer.

## Ellipsometry

- Phase delay: shift between s- and p-polarisation states of light upon reflection from a surface
- Removal of phase delay provides increased polarisation control

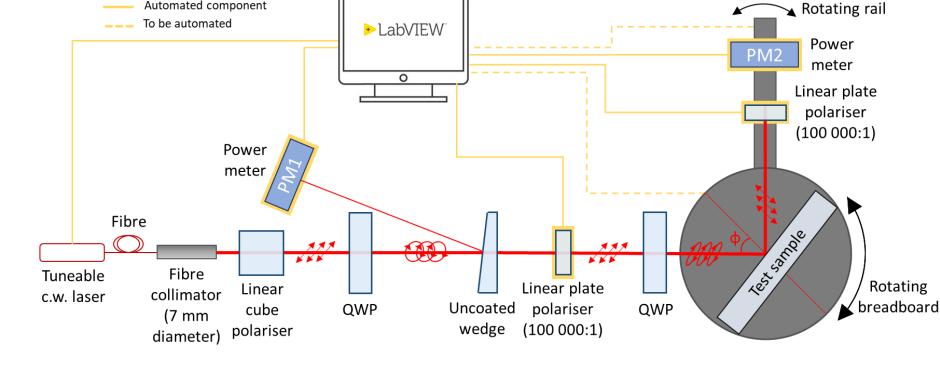
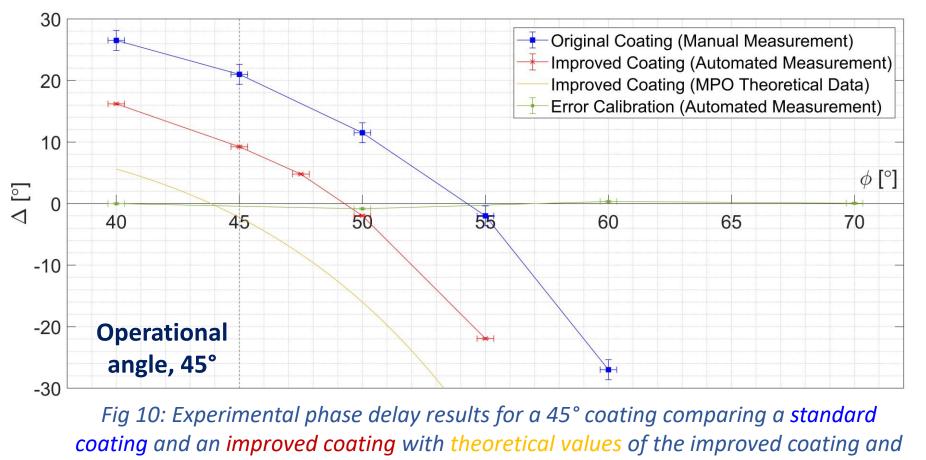


Fig 9: Layout of the partially automated **null ellipsometer** used for characterising phase delay introduced by high-reflection coatings over a range of angles,  $\phi$ , and wavelengths upon reflection.



error calibration measurements from Figure 9.

• Experimental data indicates that this value is higher than theory suggests

operational angle is zero

 Errors between theoretical and experimental phase profiles arise from the manufacturing process

Theoretical data from coating design

software suggests the phase delay

introduced by the coating at the

## **Angle-Resolved Scatter**

- Low scatter from coatings prevents other components in the laser from overheating, e.g. optomechanics
- Scatter from 45° HR coatings should be < 100 ppm/sr
- Low scatter also reduces losses and increases efficiency

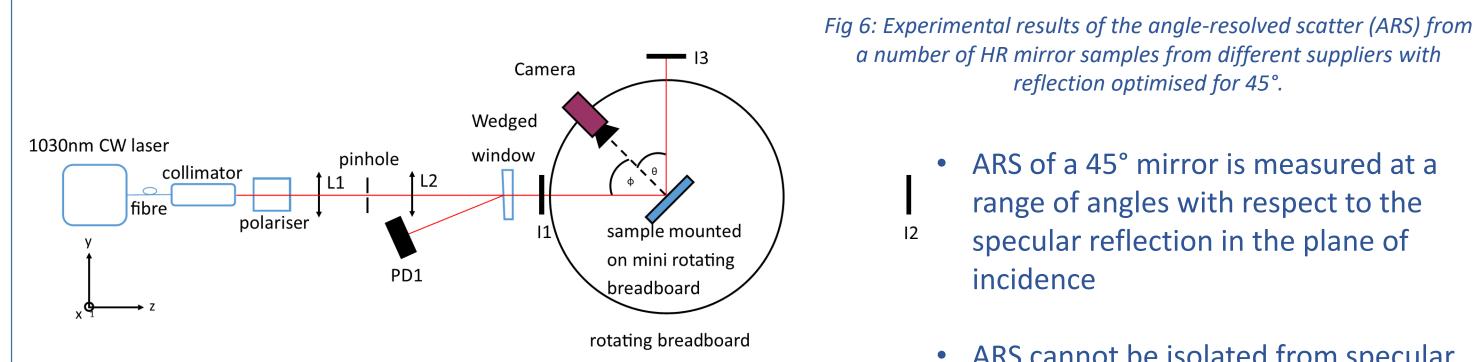


Fig 5: Layout of the setup used for measuring the angle-resolved scatter of optical

incidence

Figure 6

[6] - S. Banerjee et al., Optics Letters, 37(11), (2012). [7] - J. Pilar et al., Proc. SPIE 10511, pp. 1 -7, (2018).

Sample A —Sample E

Sample C

-Sample F

-Sample G









- [2] R. Sundar et al., Lasers Manuf. Mater., 6, pp. 424-463, (2019).
- [3] R. Betti and O. A. Hurricane, Nature Physics, 12, pp. 435-448, (2016). [4] - C. M. Brenner et al., Plasma Phys. Control. Fusion, 58, 014039 (2016). [9] - https://www.clf.stfc.ac.uk/Pages/DiPOLE-100Hz.aspx
- [8] S. Banerjee et al., HPL Sci. and Eng., 8(20), (2020).